



PATENT
03345-P0017A WWW/GJL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Michael Heuken, <i>et al.</i>
Serial No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1765
Examiner	Matthew J. Song

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Preliminary Amendment in
Request for Continued Examination Under 37 C.F. R. §1.114

Applicants herewith present Amendments and Remarks in the Request for Continued Examination in the above U.S. patent application. Please amend the Claims as set forth below.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

October 10, 2003


Caroline Gahagan

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